

Notice of References Cited	Application/Control No. 10/531,299	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Cecilia M. Jaisle	Art Unit 1624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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	N	WO 03/042242 /	05-2003	WIPO	Reiter, et al.	
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NON-PATENT DOCUMENTS

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